



LIST OF PUBLICATIONS CITED BY APPLICANT		Atty Docket No. 0553-0401		Serial No. 10/807,692		
		Applicant Yoshifumi TANADA				
		Filing Date March 24, 2004		Group 2819		
<b>U.S. PATENT DOCUMENTS</b>						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
	US 2001/0035526 A1	11/01/01	Yamazaki et al	257	57	04/24/01
	US 2001/0040565 A1	11/15/01	Koyama	345	204	05/11/01
	US 2002/0130675 A1	09/19/02	Hiroki	324	750	03/18/02
	US 2002/0132383 A1	09/19/02	Hiroki et al	438	17	03/18/02
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	6,850,080 B2	02/01/05	Hiroki	324	750	03/18/02
	US 2005/0212044 A1	09/29/05	Hiroki	257	347	01/21/05
<b>FOREIGN PATENT DOCUMENTS</b>						
	DOCUMENT NUMBER	DATE	APPLICANT	English Abstract	English Trans.	FILING DATE
	JP 2002-014337	01/18/02	Semiconductor Energy Lab Co. Ltd	X		04/26/01
	JP 2002-032035	01/31/02	Semiconductor Energy Lab Co. Ltd	X		05/10/01
	JP 2002-350513	12/04/02	Semiconductor Energy Lab Co. Ltd	X		03/12/02
	JP 2003-031814	01/31/03	Semiconductor Energy Lab Co. Ltd	X		03/19/02

**OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS**

(Include name of author (in CAPITAL LETTERS), title of article or item (book, magazine, journal, serial, symposium, catalog, etc.) date, pages(s), volume-issue number(s), publisher, city and/or country where published).

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